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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/900,054	07/06/2001	Yi-Chuan Ding	JCLA6831	7810

7590
J.C. Patents, Inc.
4 Venture
Suite 250
Irvine, CA 92618

09/08/2003

EXAMINER

NGUYEN, KHIEM D

ART UNIT PAPER NUMBER

2823

DATE MAILED: 09/08/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

Application No.

09/900,054

Applicant(s)

DING ET AL.

Examiner

Khiem D Nguyen

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-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).
- Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 13 June 2003.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1-12 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 1-12 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☒ The drawing(s) filed on 06 July 2001 is/are: a) ☒ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- 11) ☐ The proposed drawing correction filed on _____ is: a) ☐ approved b) ☐ disapproved by the Examiner.
If approved, corrected drawings are required in reply to this Office action.
- 12) ☐ The oath or declaration is objected to by the Examiner.

Priority under 35 U.S.C. §§ 119 and 120

- 13) ☒ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
a) ☒ All b) ☐ Some * c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
2. ☐ Certified copies of the priority documents have been received in Application No. _____.
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).
* See the attached detailed Office action for a list of the certified copies not received.
- 14) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).
a) ☐ The translation of the foreign language provisional application has been received.
- 15) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.

Attachment(s)

- 1) ☒ Notice of References Cited (PTO-892) 4) ☐ Interview Summary (PTO-413) Paper No(s). _____
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948) 5) ☐ Notice of Informal Patent Application (PTO-152)
- 3) ☐ Information Disclosure Statement(s) (PTO-1449) Paper No(s) _____ 6) ☐ Other: _____

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 06-13-2003 has been entered. A new rejection is made as set forth in this Office Action. Claims (1-12) are pending in the application.

Claim Rejections - 35 USC § 103

1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.
2. Claims 1-6 are rejected under 35 U.S.C. 103(a) as being unpatentable over Egawa et al. (U.S. Patent 6,376,278) in view of Belke, Jr. et al. (U.S. Patent 6,326,241) and Hung (U.S. Patent 6,380,624).

Egawa teaches a flip chip packaging process comprising (See col. 4, line 9 to col. 8, line 9 and FIGS. 2(A)-9(A)):

providing a wafer 12 having a plurality of chips 18 formed thereon, wherein each chip has an active surface 18a (FIG. 2A);

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providing a plurality of individual substrates 28, wherein each substrate includes a plurality of package units (FIGS. 2(A)-(C) and 8(A)-(C));

respectively mounting the substrates onto the wafer such that each package unit corresponds to each chip wherein two neighboring substrates are separated by a gap (col. 4, lines 9-17 and FIG. 2B);

filling an underfill material 34 between the substrates and the wafer, wherein the underfill material being introduced through the gaps between the substrates and from the boundary of the wafer (col. 4, lines 35-47 and FIG. 2C);

solidifying the underfill material (col. 4, line 45); and

dicing the wafer and the substrates to form a plurality of individualized packages 66, each individualized package including one chip and one package unit wherein the surface of each package unit is equal to the active surface of the corresponding chip (col. 7, lines 55-62).

Egawa fails to teach that each chip has an active surface provided with a plurality of bonding pads and each package unit having a plurality of contact pads wherein a gold bump is formed on each bonding pad and the contact pads are respectively connected to the corresponding bumps as recited in present claims 1 and 5.

Belke teaches a flip-chip¹² has an active surface provided with a plurality of bonding pads 14 and a substrate having a plurality of bonding pads 20 wherein a gold bump 16 is formed on each bonding pad of the flip-chip and the bonding pads of the substrate are respectively connected to the corresponding bumps (col. 4, line 58 to col. 5, line 12 and FIGS. 1-2). It would have been obvious to one of ordinary skill in the art of

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making semiconductor devices to incorporate Belke's teaching into Egawa's method because doing so can provide the electrical inputs and outputs to the flip-chip 12 (col. 4, lines 63-66 and FIGS. 1-2).

Egawa fails to teach that each substrate includes a plurality of patterned conductive layers alternately laminated with a plurality of insulating layers wherein the material of the insulating layer is FR-4, FR-5, bismaleimide triazine (BT), polyimide, or materials composite of epoxy and ceramic as recited in present claims 2-4.

Hung teaches a substrate 228 includes a plurality of patterned copper films (236a and 236b) alternately laminated with a plurality of insulating layers 230 wherein the material of the insulating layer is FR-4, FR-5 and bismaleimide triazine (BT) (col. 4, lines 6-20 and FIG. 4). It would have been obvious to one of ordinary skill in the art of making semiconductor devices to incorporate Hung's teaching into Egawa's method because doing so can make the production and the assembly of the memory module easier (col. 1, lines 65-67).

3. Claims 7-12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Egawa et al. (U.S. Patent 6,376,278) in view of Belke, Jr. et al. (U.S. Patent 6,326,241) and Hung (U.S. Patent 6,380,624).

Egawa teaches a flip chip packaging process comprising (See col. 7, line 2 to col. 8, line 9 and FIGS. 7-9(A)):

providing a wafer 12 having a plurality of chips 18 formed thereon, wherein each chip has an active surface 18a (FIG. 2A);

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providing a plurality of individual substrates 28, wherein each substrate includes a plurality of package units (FIGS. 2(A)-(C) and 8(A)-(C)) ;

respectively mounting the substrates onto the wafer such that each package unit corresponds to one chip wherein two neighboring substrates are separated by a gap (col. 4, lines 9-17 and FIG. 2B);

filling an underfill material 34 between the substrates and the wafer, wherein the underfill material being introduced through the gaps between the substrates and from the boundary of the wafer (col. 4, lines 35-47 and FIG. 2C);

solidifying the underfill material (col. 4, line 45); and

dicing the wafer and the substrates to form a plurality of individualized packages 66, each individualized package including one package unit and one chip wherein the surface of each package unit is equal to the active surface of the corresponding chip (col. 7, lines 55-62).

Egawa fails to teach that each chip provided with a plurality of bonding pads and each package unit having a plurality of contact pads wherein a gold bump is formed on each contact pad and the bonding pads are respectively connected to the corresponding bumps as recited in present claims 7 and 11.

Belke teaches a flip-chip 12' has an active surface provided with a plurality of contact pads 20' and a substrate 18' having a plurality of bonding pads 14' wherein a gold bump 16' is formed on each bonding pad of the substrate and the contact pads of the flip-chip are respectively connected to the corresponding bumps (col. 4, lines 66-67 and col. 6, lines 30-48 and FIGS. 2-3). It would have been obvious to one of ordinary skill in

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the art of making semiconductor devices to incorporate Belke's teaching into Egawa's method because doing so can provide the electrical inputs and outputs to the flip-chip 12 (col. 4, lines 63-66 and FIG. 3).

Egawa fails to teach that each substrate includes a plurality of patterned conductive layers alternately laminated with a plurality of insulating layers wherein the material of the insulating layer is FR-4, FR-5, bismaleimide triazine (BT), polyimide, or materials composite of epoxy and ceramic as recited in present claims 8-10.

Hung teaches a substrate 228 includes a plurality of patterned copper films (236a and 236b) alternately laminated with a plurality of insulating layers 230 wherein the material of the insulating layer is FR-4, FR-5 and bismaleimide triazine (BT) (col. 4, lines 6-20 and FIG. 4). It would have been obvious to one of ordinary skill in the art of making semiconductor devices to incorporate Hung's teaching into Egawa's method because doing so can make the production and the assembly of the memory module easier (col. 1, lines 65-67).

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Khiem D Nguyen whose telephone number is (703) 306-0210. The examiner can normally be reached on Monday-Friday (8:00 AM - 5:00 PM).


If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on (703) 306-2794. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 746-9179 for regular communications and (703) 746-9179 for After Final communications.

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Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

K.N.

August 19, 2003



W. David Coleman
Primary Examiner